

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Hiroshi, et al.  
Appl. No.: 10/563,630  
Conf. No.: 1962  
Filed: March 6, 2006  
Title: NITRIDE SEMICONDUCTOR DEVICE AND METHOD FOR  
PREPARATION THEREOF  
Art Unit: 2818  
Examiner: David J. Goodwin  
Docket No.: 118075-002

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO RESTRICTION REQUIREMENT**

Sir:

This Response is submitted in response to the Office Action dated August 24, 2007.